

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Kisakibaru	Art Unit:	2823
App. No.:	10/537,133	Examiner:	William D. Coleman
Filing Date:	June 2, 2005	Conf. No.:	8488
For:	Air-curtain Forming Apparatus for Wafer Hermetic Container in Semiconductor-Fabrication Equipment of Minienvironment System		

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Dear Sir:

In response to the Notice of Allowance and Notice of Allowability dated April 23, 2008, Applicant submits herewith the following comments on the statement of reasons for allowance.

The Examiner states that the prior art does not anticipate nor render obvious an air-curtain having an injection slit and a guide slit with cylindrical shaped filters such that air supplied to an air supply tube passes through the injection slit and passes through the guide slit. However, the injection slit, guide slit, and cylindrically shaped filters are not all included in independent claims 4 and 7. For example, neither claim 4 nor claim 7 includes a guide slit.

Applicant appreciates the Examiner allowing all the pending claims.

Respectfully submitted,

DATE: July 22, 2008

/Kathryn E. Noll, #48,811/

Kathryn E. Noll
Reg. No. 48,811
Attorney for Applicant

BROMBERG & SUNSTEIN LLP
125 Summer Street
Boston, MA 02110-1618
Tel: 617 443-9292
Fax: 617 443-0004